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on November 18, 2009

PATENT  
Attorney Docket No.: 16869S-095400US  
Client Ref. No.: W1204-1

TOWNSEND and TOWNSEND and CREW LLP

By: /Kelly Pedersen/

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Hisae SHIBUYA, et al.

Application No.: 10/672,010

Filed: September 25, 2003

For: METHOD AND APPARATUS FOR  
ANALYZING DEFECT DATA AND A  
REVIEW SYSTEM

Customer No.: 20350

Confirmation No.: 7689

Examiner: Alex Kok Soon Liew

Technology Center/Art Unit: 2624

AMENDMENT AFTER FINAL

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Examiner:

In response to the Final Office Action mailed August 18, 2009 on the above-referenced application, please enter the following amendments and remarks:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.